

# Printed electrodes structures as capacitive humidity sensors: A comparison

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**Abstract-** This work discusses about four planar printed capacitive sensors with different geometrical layouts, fabricated by inkjet printing on a flexible substrate and used as humidity sensors. In particular, we show a comparison among interdigitated electrodes, meandered electrodes, spiral electrodes, and serpentine electrodes in terms of fabrication yields, sensitivities to relative humidity as well as thermal drift taking into account frequency dependencies. In addition, numerical simulations have been performed to further investigate the characteristics of these sensors. All sensors present similar behavior in frequency with humidity. Taking into account sensitivity within the same sensing area, the highest value is achieved by serpentine electrodes, followed by spiral electrodes, interdigitated and meandered electrodes, in this order. The best configuration will be dependent on the specific application and its requirements.

**Keywords:** *interdigitated electrodes; serpentine electrodes; spiral electrodes; meandered electrodes; inkjet printing; capacitive humidity sensors; comparison*

## 1. Introduction

Capacitive structures are widely used in electronics to address many different applications [1]; they are especially interesting in the field of sensors due to their characteristics, such as low energy consumption, non-intrusive and non-invasive, no radiation and fast response [2, 3]. The most common sensing capacitive structures are the parallel plate (PP) and the interdigitated electrode (IDE). PP is characterized by the simplicity of its geometry and the ease of calculation and modelling.

34 IDE sensors are a particular case of planar capacitive structures where the sensor  
35 electrodes are placed in a co-planar plane [4]. The planar structure allows to access the  
36 device from only one side [5], which is particularly useful when the access to an material  
37 under test (MUT) is limited or the other side should be open to the ambient. The advantage  
38 of this kind of structures is the fact that they can be fabricated on a substrate by deposition  
39 of a layer without including any step of micromaching. That allows compatibility with  
40 any kind of technology. Furthermore, this geometry has been used to fabricate with  
41 multiple materials and following different manufacturing process, from integration in  
42 semiconductor dices to printing on flexible substrates [6-8]. This additional feature makes  
43 planar capacitive sensors an attractive option for applications in material characterization  
44 [5], non-destructive testing (NDT) [9], proximity/displacement measurement [10],  
45 intelligent human interfacing [11], and imaging [12, 13]. Many efforts have been devoted  
46 to the theoretical modelling of the planar capacitive structures. Igreja et al. [14] presented  
47 a theoretical model of the capacitance of IDE structure. These capacitors have also been  
48 simulated using different simulations tools [15-17]. Some authors have analysed other  
49 designs such as spiral electrodes and concentric rings in order to improve the performance  
50 of this design [7, 18, 19]. Other structures such as rectangular-shaped [20] and comb-  
51 shaped sensor arrays [21] were studied, showing that desired linearity and sensitivity can  
52 be achieved by the optimal selection of a set of structural parameters. Zeothout et al. [22]  
53 analyzed a rectangular shaped planar sensor using a numerical method and also compared  
54 its performance according to different material properties and boundary conditions.

55 On the other hand, flexible electronic devices manufactured by printing techniques have  
56 become increasingly attractive thanks to their feasibility of large scale processing,  
57 potential low-cost per surface area and mechanical flexibility. Great advances have been  
58 achieved in the design of flexible and printed humidity sensors [23-26] as well as sensors  
59 for other gases and vapours [27-29]. The classical transduction mechanism of these  
60 humidity sensors is capacitive due to the requirement of low energy consumption, in  
61 particular, through changes in the electrical permittivity of some structural layer of the  
62 capacitor or the dielectric thickness. Different printed techniques have been used to  
63 manufacture capacitive printed devices and different approaches have been followed to  
64 add the sensing capability into the capacitor. The most common strategy has been to  
65 deposit a sensing layer over the electrodes [16, 30, 31] such as cellulose acetate butyrate  
66 (CAB), poly(methyl methacrylate) (PMMA) or polyvinylchloride (PVC), among others.

67 Another possibility has been to select a flexible substrate as sensing element saving  
68 fabrication steps, in this sense, polyimide [26] and photographic paper [25] have already  
69 been used. One of the main interfering factors to obtain an accurate humidity  
70 measurement is temperature. In order to compensate this dependence, several strategies  
71 have been already described such as differential measurements with reference capacitors  
72 (not sensitive to humidity) [32], including additional temperature sensors [33, 34] or using  
73 a sensitive layer with very low thermal drift [35, 36]. This latter alternative does not  
74 require additional devices, and therefore, less area and energy is consumed.

75 In this work, we will show the design, fabrication and characterization as humidity sensor  
76 of four different coplanar electrodes comparing and contrasting their characteristics. In  
77 this regard, we present the design, fabrication and characterization of capacitive humidity  
78 sensors which uses the flexible substrate as sensitive element. These capacitors have been  
79 printed with silver nanoparticles ink by inkjet-printing on a polyimide thin film. In the  
80 context, this paper discusses planar printed capacitive sensors in terms of fabrication  
81 yields, sensitivity to relative humidity as well as thermal drift taking into account  
82 frequency dependencies. Further investigations of the sensor designs have been carried  
83 out using a numerical method. The differences among these planar capacitive sensors are  
84 pointed out as well as their advantages and disadvantages of the different electrodes  
85 designs.

## 86 **2. Materials and methods**

### 87 *A. Fabrication process*

88 The DMP-2831™ Dimatix printer (Fujifilm Dimatix Inc, Santa Clara, USA) was used for  
89 inkjet printing. The selected materials were an ink of silver nanoparticles (U5603  
90 SunTronic Technology, San Diego, USA) on a polyimide substrate (Kapton® HN with  
91 75 μm of thickness, Dupont™). Table 1 shows the main properties of the used ink and  
92 substrate, respectively.

93 According to the manufacturer of the substrate, the relationship between the relative  
94 permittivity ( $\epsilon_r$ ) and the relative humidity (RH) is given by:

$$95 \quad \epsilon_r = 3.05 + 0.008 \cdot RH(\%) \quad \text{at } 1 \text{ kHz, } 23 \text{ }^\circ\text{C} \quad (1)$$

96 The first step before printing was to prepare the substrate removing all traces of particles  
97 with a cleaning process to ensure the best quality and to avoid failed printings. First, the  
98 substrate was immersed in acetone for 2 min to remove dust on the surface, and then was  
99 submerged in propanol about 2 min to remove the acetone. After that, the substrate was  
100 washed with purified water to eliminate the propanol and finally was dried at 120°C for  
101 5 min. During the printing process the substrate temperature was fixed at 40°C and a drop  
102 space of 25  $\mu\text{m}$  was settled for 50  $\mu\text{m}$  landed diameter drops. Finally, a sintering step is  
103 carried out at 120 °C for 60 min.

104 In order to know the thickness of the printed layer, the theoretical model given in [37]  
105 has been used. According to this model, the amount of used ink is 22.7 nl for one printed  
106 layer with a thickness of 460 nm. With that printing and curing conditions, the resistivity  
107 of the conductive electrodes were  $23 \pm 2 \mu\Omega \cdot \text{cm}$  [37]. The fabrication time is much shorter  
108 than in the case of other sensors because no other sensing layer was needed [16, 30, 31].  
109 The fabrication process is also simplified because it only required printing one layer on  
110 one side of the substrate. In a previous work, we demonstrated that thickness layer does  
111 not contribute significantly to capacitance and therefore the definition of electrodes by  
112 only one printed layer is enough for a proper sensor performance [35]. A matrix of twenty  
113 capacitors of each type was fabricated in order to test the reproducibility of the process.

#### 114 *B. Physical and electrical characterization*

115 The geometrical characterization, the roughness of printed patterns as well as the  
116 thickness of the patterns have been measured using a Wyko NT1100 Optical Profiling  
117 System (VEECO, Tucson, AZ, USA), and a Dektak XT™ Stimulus Surface Profiling  
118 System (Bruker Corporation, Coventry, UK).

119 The AC electrical characterization for the different fabricated capacitors has been  
120 performed by measuring their capacitance and dissipation factor, using the four-wire  
121 measurement technique with a precision Impedance Analyser 4294A and an impedance  
122 probe kit (4294A1) (Agilent Tech., Santa Clara, CA, USA). The excitation voltage  
123 applied in all measurements was  $V_{\text{DC}} = 0$  and  $V_{\text{AC}} = 500 \text{ mV}$ . The frequency sweep of  
124 analysis was from 100 kHz to 10 MHz. In all prototypes, one of the end sides has been  
125 enlarged to facilitate its connection to any analyser. A SMA (SubMiniature version A)  
126 male connector has been glued to these ends points using silver-filled epoxy EPO-TEK®  
127 H20E (Epoxy Technology, Inc., Billerica, USA). A complete compensation method has

128 been implemented to eliminate the contribution of parasitic capacitances by measuring  
129 several commercial capacitances placed in the same configuration as the devices under  
130 test with the 16034G surface mount device (SMD) Test Fixture (Agilent Tech., Santa  
131 Clara, CA, USA).

132 The stationary humidity and temperature responses of the sensors have been measured in  
133 a climatic chamber VCL 4006 (Vötsch Industrietechnik GmbH, Germany). The humidity  
134 deviation in time was  $\pm 1\%$  to  $\pm 3\%$ , whereas the temperature deviation in time was  $\pm 0.3$   
135  $^{\circ}\text{C}$  to  $\pm 0.5$   $^{\circ}\text{C}$ . The data acquisition and analysis have been automated using Labview  
136 2012 software (National Instruments Corporation, Texas, USA). Due to the slow response  
137 of the mentioned climatic chamber, the dynamic response has been measured in a  
138 customized humidity measurements set-up ( $9 \times 3$   $\text{cm}^2$ ), which automatically controls wet  
139 and dry airflow inside a small gas cell at room temperature. Two LCR-meters (HP 4284L  
140 and Agilent E4980A, Agilent Tech., Santa Clara, CA, USA) have been used to measure  
141 the corresponding capacitance values at a frequency of 100 kHz every 5 s. Capacitance  
142 and time measurements of the printed sensors have been controlled and recorded using  
143 the software Labview 2012. RH and temperature measurements have been also registered  
144 by a commercial sensor (SHT15, Sensirion AG, Switzerland) in order to verify the data  
145 given by the chambers' displays. In all cases, the capacitors have been placed in the  
146 middle of the climatic chambers allowing the atmosphere interaction in both faces of the  
147 sensors, printed and non-printed.

### 148 *C. Electrodes designs*

149 We have analysed four different electrodes configurations as capacitive sensor. In this  
150 section, we present the geometry of each device, pointing out the dimensions and areas  
151 of the fabricated capacitors.

#### 152 **Interdigitated electrodes**

153 First, interdigitated electrodes (Figure 1a) have been studied. As we mentioned before,  
154 this structure is the most common one to develop planar capacitive sensors thanks to its  
155 compromise between ease of manufacturing and performance. Table 2 presents the  
156 dimensions of the modelled IDE sensor, resulting in a designed area of  $11.65$   $\text{mm}^2$  ( $L =$   
157  $1.85$   $\text{mm} \times W = 6.3$   $\text{mm}$ ) and a capacitance of  $1.97$   $\text{pF}$  at dry atmosphere calculated by  
158 numerical simulation.

### 159 **Meandered electrodes**

160 Meandered electrodes have been developed as capacitive sensor as shown in Figure 1b.  
161 Although this geometry shows at first glance lower contact area than the previous ones,  
162 it could result interesting in some applications, as we will describe in the following  
163 section. The designed sensor structure area is  $89.0 \text{ mm}^2$  ( $L = 4.00 \text{ mm} \times W = 22.25 \text{ mm}$ )  
164 following specifications shown in Table 3 and the numerical capacitance is  $3.14 \text{ pF}$  at dry  
165 atmosphere.

### 166 **Spiral electrodes**

167 Another studied structure has been the spiral electrodes. This structure has been  
168 previously reported by [18, 38] to achieve a high compactness. In this case, the electrodes  
169 are placed as a coil inductor (Figure 1c). Table 4 shows the physical dimensions of the  
170 modelled spiral capacitor with a total area of  $5.52 \text{ mm}^2$  ( $L = 2.35 \text{ mm} \times W = 2.35 \text{ mm}$ )  
171 and numerical capacitance of  $0.91 \text{ pF}$  at dry atmosphere.

### 172 **Serpentine electrodes**

173 Finally, this periodic electrode structure consists of a combination of meandering and  
174 interdigitated electrodes in a serpentine-shaped geometry [36] (Figure 1d). Serpentine  
175 electrodes (SRE) were previously used as electrode guard of IDE structures [39],  
176 impedance sensor for conformal skin hydration monitoring [40] or a three phase electrode  
177 array for AC electro-osmotic flow pumping [41]. SRE geometry is describe in Table 5,  
178 covering a total area of  $11.65 \text{ mm}^2$  ( $L = 1.85 \text{ mm} \times W = 6.3 \text{ mm}$ ). The numerical  
179 capacitance of this structure is  $2.26 \text{ pF}$  at dry atmosphere.

## 180 **3. Results and discussion**

### 181 *A. Simulation results*

182 With the aim of structure optimizations and after different simulations varying the  
183 fundamental geometrical parameters, we have used COMSOL Multiphysics 4.2a  
184 ([www.comsol.com](http://www.comsol.com), COMSOL, Inc. USA). This is a powerful interactive tool for solving  
185 problems based on partial differential equations with the finite element method. This  
186 software has previously been used to calculate distributions of potential field in this kind  
187 of structures [17, 34]. The equations solved in the determination of the capacitance in  
188 each finite element are:

189 
$$-\nabla\varepsilon_0\varepsilon_r\nabla V = \rho \quad (\text{Eq. 2})$$

190 
$$\mathbf{D} = \varepsilon_0\varepsilon_r\mathbf{E} \quad (\text{Eq. 3})$$

191 where  $\rho$  is the charge density,  $\mathbf{D}$  is the electric displacement, and  $\mathbf{E}$  is the electric field.  
192 The electrostatic energy density needed to charge a capacitor is equal to that energy of  
193 the electrostatic field, and is given by:

194 
$$W_e = \int_{\Omega} DEd\Omega \quad (\text{Eq. 4})$$

195 Then, the total capacitance is determined by the integral of the electric energy density  
196 through the relation:

197 
$$C = \frac{2}{V_{port}^2} \int_{\Omega} W_e d\Omega \quad (\text{Eq. 5})$$

198 where  $V_{port}$  is the value of the applied voltage in the port of the sensor. The other electrode  
199 is connected to ground. The electrical parameters of the substrate given by the  
200 manufacturer and the printed and cured conductive silver ink according to our  
201 characterization were included in the numerical simulator [37].

202 The main results obtained are summarized as follow:

- 203
- 204 • If the sensing strategy is based on a sensitive substrate, the influence of the  
205 electrode thickness is virtually negligible in comparison with the other  
206 geometrical features. This result has been appreciated in all simulated structures.
  - 207 • Keeping fixed gap between electrodes and their width, the bigger the structure,  
208 the bigger its capacitance and therefore, the sensitivity is enhanced.
  - 209 • Regarding the capacitance in the same substrate area, simulations show that SRE  
210 presents the greatest value followed by spiral electrodes, IDE and meandered  
electrodes.

## 211 *B. Physical characterization*

212 Twenty samples of each type of electrode configuration were fabricated with just one  
213 printed layer. To experimentally check the simulated layouts, the replicas of each  
214 structure were physically characterized. According to a previously developed physical  
215 model of thickness layer by inkjet printing [16, 37], the calculated thicknesses are 430

216 nm for one printed layer. The measured dimensions of the structures are presented in  
217 Table 6 for IDE and SRE, Table 7 for spiral electrodes and Table 8 for meandered  
218 electrodes, showing the differences between measured and modelled dimensions.  
219 Uncertainties were calculated as one standard deviation of the experimental data.  $R_a$  is  
220 the arithmetic average of the absolute values, both of the surface roughness height and  $R_q$   
221 is the root mean square (RMS).

222 In general, predicted and experimental dimensions are quite similar, although the bigger  
223 discrepancies are found in electrodes width and interspacing. As explained by Derbi et al.  
224 [42], printing electronics techniques present undesirable effects resulting in an inaccuracy  
225 on the printed structure, such as wider fingers and narrower inter-spacing. **Table V**  
226 **summarizes the main features of each electrode configuration.**

227 The yield rate was estimated from the low frequency capacitance measurements of the  
228 several replicas of each type of capacitor. During these tests, a preliminary manufacturing  
229 yield of 90% was found for IDE (including samples totally and partially broken) and  
230 meandered capacitors whereas lower values were found for spiral and serpentine  
231 electrodes, about 80%. This lower manufacturing yield is directly associated with the  
232 higher complexity of the latter configurations with respect to the former ones. It should  
233 be highlighted that in the case of IDE capacitors the device works when there is any  
234 broken finger, being the only effect a decreased in the total capacitance. In the other  
235 configuration studied, capacitors are totally useless when there is any printing error.  
236 Therefore, the manufacturing yield of IDE capacitors would be about 95% if we admit  
237 broken fingers. Comparing SRE and spiral electrodes, the manufacturing yield obtained  
238 is virtually the same but taking into account that spiral electrodes are about half area of  
239 SRE devices, this yield should be lower in the case of spiral electrodes if we have  
240 fabricated these capacitors with double area. An easy way to avoid the increase of failure  
241 is to connect in parallel this device, so that the equivalent capacitance is equal to the sum  
242 of individual values.

### 243 *C. RH Sensitivity and Thermal drift*

244 For five capacitors of each electrode configuration, the capacitances have been measured  
245 from 100 kHz to 10 MHz as a function of the relative humidity and temperature. In order  
246 to gain a better understanding of the whole sensor responses eliminating the area  
247 influence, we have defined the area-normalized partial sensitivities of the capacitance



248 with the relative humidity,  $S_{RH}(f)$ , and the temperature,  $S_T(f)$  as a function of the  
249 measurement frequency,  $f$ , as:

$$250 \quad S_{RH}(f) \equiv \left. \frac{\partial C (RH)}{A \partial RH} \right|_{T=cte} \quad (2)$$

$$251 \quad S_T(f) \equiv \left. \frac{\partial C (T)}{A \partial T} \right|_{RH=cte} \quad (3)$$

252 where  $A$  corresponds to the structure area. The humidity response has been calculated in  
253 a range from 20%RH to 90%RH at constant temperature of 40 °C, while the thermal drift  
254 has been obtained in a range from 20 °C to 50 °C at constant moisture content (50%RH).

255 **The RH sweeps were performed in both directions in steps of 10%RH while temperature**  
256 **sweeps were performed in both directions in steps of 5°C.**

257 Figure 2 shows the comparison of the sensitivity to relative humidity of each sensor as a  
258 function of frequency. All sensors show a similar trend in frequency, a relative higher  
259 value at lower frequencies and sensitivity trends to a constant value at higher frequencies.

260 In terms of performance, SRE shows the highest normalized sensitivity values, followed  
261 by spiral electrodes and IDE. Meandered electrodes present the lowest value. For  
262 example, the normalized RH sensitivity at 1 MHz is 0.44 fF/%RH·mm<sup>2</sup> for SRE, 0.42  
263 fF/%RH·mm<sup>2</sup> for spiral electrodes, 0.36 fF/%RH·mm<sup>2</sup> for IDE and 0.06 fF/%RH·mm<sup>2</sup>  
264 for meandered electrodes. Whereas the same sensitivities at 100 kHz is 0.52  
265 fF/%RH·mm<sup>2</sup> for SRE, 0.48 fF/%RH·mm<sup>2</sup> for spiral electrodes, 0.38 fF/%RH·mm<sup>2</sup> for  
266 IDE and 0.06 fF/%RH·mm<sup>2</sup> for meandered electrodes. As can be observed, the sensitivity  
267 is virtually no affected by frequency in the case of meandered electrodes.

268 Looking at the displacement vector, the highest values are found in all the structures  
269 around the edges regions, with SRE and spiral electrodes being the designs that show  
270 more area at highest value due to the fact that they present more edges than the other two  
271 configurations (see Figure 3). This result can explain the capacitance values obtained.

272 The electric displacement field varies the charge stored between the sensor electrodes  
273 and, therefore, alters the inter-electrode capacitance (see Eq. 3 to 5 above). This can be  
274 used to infer the properties of the material under test, in this case, the humidity sensitive  
275 substrate. These results agree with the study of the capacitance sensitivity as a function  
276 of the structure shape by Hu et al. [4] where meandered shapes (interdigitated and spiral  
277 electrodes) showed higher sensitivities.

278 Figure 4 presents the normalized thermal drift of each electrode design. Depending on the  
279 specific application and its requirements, we could choose a configuration or another. For  
280 example, SRE and spiral electrodes should be selected when sensitivity is a critical factor.  
281 In addition, depending on the shape where the sensor is going to be placed could be better  
282 the key requirement to select the electrode shape. But these two designs are more complex  
283 than the other two and, therefore, their yield rates are lower than the other two  
284 configurations.

285 IDE electrodes show the best compromise between sensitivity, area and manufacturing  
286 yield. Although meandered electrodes show the lowest performance, this configuration  
287 can be very useful to develop more complex sensor configurations such as double sensor  
288 as presented in [43]. Furthermore, the distance between electrodes in this latter design  
289 can be reduced and the performance could be closer to the other capacitors. In particular,  
290 the simulated capacitance obtained is  $0.12 \text{ pF/mm}^2$  when width1 and width2 are  $150 \text{ }\mu\text{m}$   
291 and  $250 \text{ }\mu\text{m}$ , respectively. This result improves four times the sensitivity obtained by  
292 simulations with the fabricated meandered sensor although lower than the capacitance  
293 obtained with the other configurations.

#### 294 *D. Time response and Time stability*

295 The dynamic response of IDE and SRE sensors present a high stability along different  
296 measurement cycles and over time. On one hand, the response time can be defined as  $t =$   
297  $\tau$ , corresponding to the 63% of the maximum value of capacitance (reached at  
298 equilibrium) for every increasing step of RH. This time is equal to  $356 \pm 3 \text{ s}$  and  $350 \pm 3$   
299  $\text{s}$  for IDE and SRE, respectively. On the other hand, the response time for desorption,  $\tau'$ ,  
300 can be described as the time associated to the 37% of the maximum value of capacitance  
301 for every decreasing step of RH; this value is  $367 \pm 4 \text{ s}$  for IDE and  $365 \pm 4 \text{ s}$  for SRE  
302 [35, 36]. These values have been calculated as the mean value of the sensor response to  
303 changes in RH from 15% to 45%, 15% to 65% and 15% to 85% at room temperature.

304 These times are virtually the same for both electrode configurations studied. The  
305 explanation to these long response times can be found in the difference between diffusion  
306 rates in the solid substrate used compared to the deposited layers in other similar  
307 structures [16, 30]. Although these printed sensors can hardly compete in terms of  
308 response time with commercial CMOS-based humidity sensors (SHT15, Sensirion AG,  
309 Switzerland) with times smaller than 10 s, this lower performance in response time should

310 not be a problem to use of these printed humidity sensors since humidity is an  
311 environmental property that often changes gradually. Furthermore, these times can be  
312 easily reduced by using a thinner substrate. Harrey et al. [44] presented a parallel-plate  
313 capacitive sensors with several humidity sensitive polymers including polyimide (Kapton  
314 HN). Indeed, they showed that the times responses achieved varied from 5 min to 10.5  
315 min for Kapton HN depending on the thickness of the film. Anyway, all these sensors as  
316 they are presented here could be applied for environmental humidity monitoring, where  
317 variations are usually gradual and slow.

318 Regarding time stability, the IDE and SRE sensors have been measured once a week for  
319 more than 6 months and the variation between data has been less than 10 fF in both cases.  
320 In order to determine the aging drift, we performed a stability test 5 months after their  
321 fabrication. After the fifth month, sensors were tested for 10 days at fixed relative  
322 humidity (30%) and controlled temperature (30°C) every 6 hours. The aging drift was  
323 less than 3%RH for both sensors, which is within the time drift specification of the used  
324 climatic chamber.

325 For the other two designs, we have not measured their dynamic responses and either their  
326 time stabilities. As we have previously studied, the response time is directly related to the  
327 square value of the thickness of the sensitive layer [45]; as we have used the same  
328 substrate, the time response should be around 350 s. The time stability is directly  
329 associated with the sensing materials. Then, as all the materials are exactly the same, we  
330 can assume that the other sensors are expected to have a long lifetime.

#### 331 **4. Conclusions**

332 In this work, we present the comparison between four different electrodes layouts:  
333 interdigitated electrodes (IDE), meandered electrodes, spiral electrodes, serpentine  
334 electrodes (SRE). These designs are planar electrodes developed in only one surface of  
335 the substrate. All these structures have been characterized as capacitive sensors, in  
336 particular, as humidity sensors. We show a comparison in terms of numerical simulations  
337 as well as experimental results. In order to measure the response of all the sensors to  
338 moisture content, we have fabricated them by inkjet printing using a silver ink on a  
339 polyimide substrate whose electrical permittivity is directly related to the relative  
340 humidity.

341 We have studied their responses to RH in a frequency range from 100 kHz to 10 MHz.  
342 Furthermore, we have looked into the thermal drift of each structure. In order to compare  
343 and contrast each response, we have normalized the values found taking into account the  
344 area occupied by each structure.

345 In terms of sensitivity to RH, all sensors show similar trends in frequency but the highest  
346 value is achieved by SRE, followed by spiral electrodes, IDE and meandered electrodes,  
347 in this order. Depending on the specific application and its requirements, we could choose  
348 a different configuration. For example, SRE and spiral electrodes should be selected when  
349 sensitivity is a critical factor. But these two designs are more complex than the other two  
350 and, therefore, their yield rates are lower than the other two configurations. Regarding  
351 IDE electrodes, it shows the best compromise between sensitivity a manufacturing yield.  
352 Finally, meandered electrodes can be easily adapted to more complex designs [43].

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